IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

PATENT

Inventors:

Kenii OTODA, et al.

Docket No.:

49288.1600

Assignee:

Mitsuboshi Diamond Industrial

Co., Ltd.

Serial No.:

10/554,855

Confirmation No. 4197

Filing Date:

October 18, 2006

Art Unit: 3724

BRITTLE SUBSTRATE

Examiner:

Clark F. Dexter

TITLE:

CUTTING SYSTEM AND

BRITTLE SUBSTRATE CUTTING METHOD

AMENDMENT AND REPLY

Mail Stop AMENDMENT Commissioner For Patents P.O. Box 1450 Alexandria, VA 22313-1450

Dear Commissioner:

In reply to the Office Action mailed on September 15, 2009, of which this Reply is filed within the one month shortened statutory period for reply, please consider the following remarks and amendments.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 20 of this paper.